	A1:4: NI	A 1: 4(-)
Notice of Allowability	Application No.	Applicant(s)
	10/798,571	NAKAJIMA ET AL.
	Examiner	Art Unit
	Mai-Huong Tran	2818
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this application of the communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. <b>THIS</b>
1. This communication is responsive to <u>1/4/05</u> .		
2. 🔀 The allowed claim(s) is/are <u>25-35</u> .		
3. $\boxtimes$ The drawings filed on <u>12 March 2004</u> are accepted by the	Examiner.	
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority ur</li> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> </ul>	e been received.	2/400 007
<ul> <li>2.  Certified copies of the priority documents have been received in Application No. 10/406,387.</li> <li>3.  Copies of the certified copies of the priority documents have been received in this national stage application from the</li> </ul>		
,	cuments have been received in this	national stage application from the
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply IENT of this application.	complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") mus  (a) ☐ including changes required by the Notice of Draftspers  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the street in the stree	son's Patent Drawing Review(PTO s Amendment / Comment or in the C .84(c)) should be written on the drawir	office action of
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT		
Attachment(s)  1. The Notice of References Cited (PTO-892)	5. Notice of Informal P	atent Application (PTO-152)
<ol> <li>Notice of References Cited (P10-892)</li> <li>District Notice of Draftperson's Patent Drawing Review (PTO-948)</li> </ol>	6. ☐ Interview Summary	,,
, , ,	Paper No./Mail Dat	e
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date <u>1/4/05</u></li> </ol>	08), 7. 🗌 Examiner's Amendn	nent/Comment
4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stateme	ent of Reasons for Allowance
of Biological Material	9. Other	
	Ch/	
David Nelms		
Supervisory Patent Examiner		
Technology Center 2800		

## **DETAILED ACTION**

## Examiner's Amendment.

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Cancel claims 1-24.

## Reason for allowance

The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed Magnetic Storage Apparatus Having Dummy Magnetoresistive Effect Element and Manufacturing Method Thereof having a first magnetoresistive effect element which functions as a memory element by patterning the magnetoresistive effect film of the memory cell portion into the first shape by using the first cap layer, and forming a second magnetoresistive effect element which functions as a dummy by patterning the magnetoresistive effect film of the peripheral circuit portion into the second shape by using the second cap layer; forming a first metal layer by patterning the first metal material film of the memory cell portion into a third shape, and forming a second metal layer by patterning the first metal material film of the peripheral circuit portion into a fourth shape.

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the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance".

Conclusion

Any comments considered necessary by applicant must be submitted no later than

Any inquiry concerning this communication on earlier communications from the

examiner should be directed to Mai-Huong Tran, (571) 272-1796. The examiner can

normally be reached on Monday-Thursday from 8:00 AM to 6:30 PM. The examiner's

supervisor, David Nelms can be reached on (571) 272-1787.

The fax phone number for the organization where this application or proceeding is

assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published

applications may be obtained from either Private PAIR or Public PAIR, Status

information for unpublished applications is available through Private PAIR only. For

more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

have questions on access to the Private PAIR system, contact the Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

Mai-Huong Tran

David Nelms
Supervisory Patent Examiner

Technology Center 2800